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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MORI, Kenichi et al.

Appl'n No.: 10/567,761

Filing Date: 10 February 2006

Group Art Unit: 1752

Examiner: n/a

For: NEAR-INFRARED RAY ABSORPTION FILM AND
PROCESS FOR ITS PRODUCTION, NEAR-INFRARED RAY
ABSORPTION FILM ROLL AND PROCESS FOR ITS
PRODUCTION, AND NEAR- INFRARED RAY ABSORPTION
FILTER

Commissioner for Patents

Office of Initial Patent Examination's Filing Receipt Corrections
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Attached is a copy of the filing receipt received from the PTO in the above-identified application for which issuance of a corrected filing receipt is respectfully requested.

The following requested change is marked on the copy of the filing receipt submitted herewith:

ERROR IN

Foreign Application
Title

CORRECT DATA

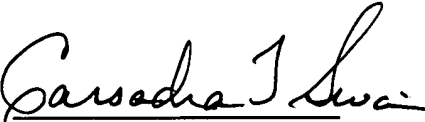
Japan 2003-432,735
Near-infrared absorbing film and process for
producing.....

The Office may charge any additional fees required under 37 C.F.R. § 1.16 or § 1.17, or credit any overpayments, to Deposit Account No. 11-0600.

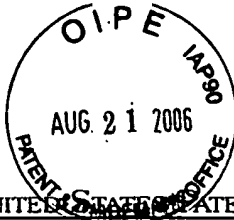
The Examiner is invited to contact the undersigned at 202-220-4200 to discuss any matter regarding this application.

Respectfully submitted,

Dated: August 21, 2006

By: 
Cassandra T. Swain, Ph.D.
(Reg. No. 48,361)

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UNITED STATES PATENT AND TRADEMARK OFFICE

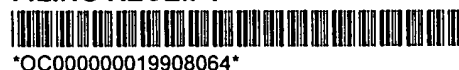
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/567,761	02/10/2006	1752	2550	1324114	3	24	4

CONFIRMATION NO. 5641

23838
 KENYON & KENYON LLP
 1500 K STREET N.W.
 SUITE 700
 WASHINGTON, DC 20005

FILING RECEIPT



OC000000019908064

Date Mailed: 08/07/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

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Power of Attorney: The patent practitioners associated with Customer Number 23838.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/11788 08/11/2004 ✓

Foreign Applications

JAPAN 2003-291785 08/11/2003 ✓
 JAPAN 2003-291787 08/11/2003 ✓
 JAPAN 2003-434288 12/26/2003 ✓
 JAPAN 2003-434735 12/26/2003 ✓
 JAPAN 2003-434290 12/26/2003 ✓
 JAPAN 2004-180939 06/18/2004 ✓

432,735



If Required, Foreign Filing License Granted: 08/04/2006

The country code and number of your priority application, to be used for filing abroad under the Paris

Convention, is **US10/567,761**

Projected Publication Date: 11/16/2006

Non-Publication Request: No

Early Publication Request: No

Title

Producing
Near-infrared absorbing film, and process for ~~production~~ the same, near-infrared absorbing film roll, process for producing the same and near-infrared absorbing filter

Preliminary Class

430

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15